of 1 Page Serial No. Atty Docket 10/827,330 26102 Applicant NAKAMURA FORM PTO-Group Art Unit Filing Date Not Yet Assigned MATION DISCLOSURE CITATION April 20, 2004 U.S. PATENT DOCUMENTS Filing . Sub-Issue Document Examiner Class Date Class Name Date Number Initial AA AB AC AD ΑE AF FOREIGN PATENT DOCUMENTS Sub-Trans-Document lation Class Class Country Date Number Abstract JΡ 31 Mar 2000-091078 MH 2000 AG Abstract JΡ 30 Nov 2001-332390 2001 AН MH Abstract JP 08 Sep 2000-243569 2000 ΑI MH Abstract JP 08 Sep 2000-243567 2000 AJMH ΑK (Including Author, Title, Date, Pertinent Pages, etc.) OTHER Abstract: 27a-A-6, Oyamada, T. et al., "OLED characteristics using low work function metals and the application for thick-film OLEDs", Proceeding Paper of the 50th applied physics associated conference in Japan, pp.1402, (March 2003). MH ALAΜ AN Date Considered 07/24/2006 Examiner /Matthew Hodges/ EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP ' 609. Draw line through citation if not in conformance and not considered.
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